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1765  
PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Kozo Nakamura

Serial No.: 09/856,209

Filed: May 18, 2001

For: **SILICON CRYSTAL AND  
PRODUCTION METHOD FOR  
SILICON SINGLE CRYSTAL  
WAFER**

Examiner: Matthew J. Song

) Art Unit: 1765

) Confirmation No.: 6736

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1450, on June 9, 2003:*

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#10018  
6/18/03  
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**AMENDMENT**

MAIL STOP FEE AMENDMENT  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action of March 4, 2003 has been carefully reviewed and the following amendments and remarks are made in response thereto.

A Petition for Extension of Time Under 37 CFR 1.136(a) is enclosed.